



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Naoto NAKAMURA et al.

Group Art Unit: 2893

Application No.: 10/528,069

Examiner: H. TRINH

Filed: July 10, 2005

Docket No.: 122733

For: THERMAL TREATMENT APPARATUS, METHOD FOR MANUFACTURING  
SEMICONDUCTOR DEVICE, AND METHOD FOR MANUFACTURING  
SUBSTRATE

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the October 27, 2008 Office Action, the period for reply being extended by  
the attached Petition for Extension of Time, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**